

**INVESTIGATION ON THE COATING OF HIGH REFRACTIVE INDEX  
QUARTER-WAVELENGTH THICK ZIRCONIUM AS A MATERIAL LAYER  
FOR DIELECTRIC MIRROR**

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**Final Year Project Report Submitted in  
Partial Fulfillment of the Requirement for the  
Degree of Bachelor of Science (Hons.) Physics  
In the Faculty of the Applied Sciences  
Universiti Teknologi MARA**

**MAY 2011**

## **ACKNOWLEDGEMENTS**

### **In the name of Allah, the Beneficent and the Merciful**

It is most humbleness and gratitude that this work is finally completed with His blessing. A lot of experiences gained in the documentation.

Firstly, I wish to acknowledge my main project supervisor, Prof Dr. Mohd Kamil Bin Abdul Rahman, my co-supervisor En. Zainizam Bin Surat and also to my friend Suriani Bt Samsuri for their support, encouragement and guidance from the very beginning until the end. Without their prompt opinions and compassion to lead in my study, this project maybe would not complete. To all my course mates, thanks for all the sharing and encouragement.

I also would like to thank the UiTM for allowing me using the equipments and the laboratory during the research work. In the deepest sense of gratitude, I must thank my beloved family for giving me their blessing to do my thesis here even though they are far. Finally, not to be forgotten to anyone that contributes on this research project whether directly or indirectly. I am sincerely grateful to all of them for their willingness to help and may Allah bless you.

Noor Fariza Binti Subari

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## ABSTRACT

Sol gel method for the preparation of  $ZrO_2$  thin film using zirconium oxychloride as the starting precursor. Thin films were deposited using dip-coating method onto silicon wafer and glass substrate. The dip-coating rate was varied from 10mm/min to 40 mm/min to obtain the exact thickness of 71.5 nm as one-quarter wavelength. The surface morphology, crystalline structure, optical properties, thickness and refractive index of  $ZrO_2$  thin film were investigated by using AFM, XRD, Uv-Vis, Surface Profiler and Prism Coupler measurement. The average surface roughness of  $ZrO_2$  thin film is about 2 nm respectively. The films present a tetragonal phase for annealing temperature 500°C. A large percent of transmission approximately 90% was present for fast dip-coating rate and very low dip-coating rate have percentage of transmission below 70%. At the dip-coating rate 10mm/min, the exact thickness of 72 nm was achieved. However, the crack formation of one layer of  $ZrO_2$  thin film was observed. Refractive index that characterize by prism coupler using wavelength,  $\lambda = 632\text{nm}$  give high refractive index for  $ZrO_2$  (2.07 -2.15).

*Keyword:* sol-gel technique; dip-coating thin films; Zirconium oxide ( $ZrO_2$ ); refractive index

# CHAPTER 1

## INTRODUCTION

### 1.1 Background of study

Mirrors commonly have a metallic coating [1] with silver (Ag) or gold (Au) which can conduct electricity. It is harmful to laser application but it is the cheapest compared other optical coating. Different from metals, dielectric mirror can reflect light more efficiently because it does not conduct electricity. Dielectric mirror is composed of multiple thin layers of dielectric materials with a high refractive index interleaved with layers of low refractive index [2]. For example,  $ZrO_2$  is used for high refractive index and  $SiO_2$  for low refractive index[3,4]. The result is high-performance mirrors that can achieve reflectivities approaching 100 percent for critical imaging and laser applications. In addition, dielectric coatings are far more durable than metallic coatings, low cost and high reflectivity that is useful in application laser. Dielectric mirrors can be fine-tuned to reflect specific wavelengths by trimming the thickness of each layer so that the product of the thickness and refractive index equals one-quarter of the target wavelength. This type of coating is termed a quarter wavelength stack reflector. Increasing the number of layers can increase the reflectance for specific wavelengths, but often at the expense of spectral bandwidth. Another drawback is that dielectric mirrors are often very sensitive to the angle of incidence and can produce undesirable plane-polarized light when incorrectly positioned.